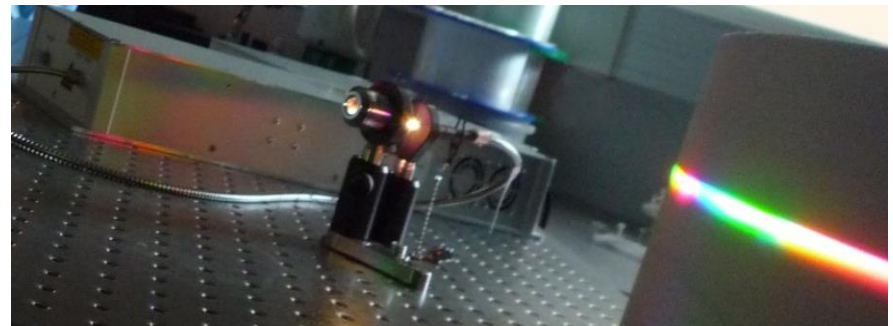
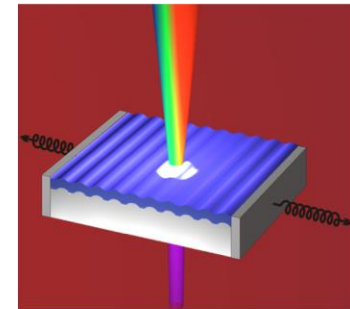
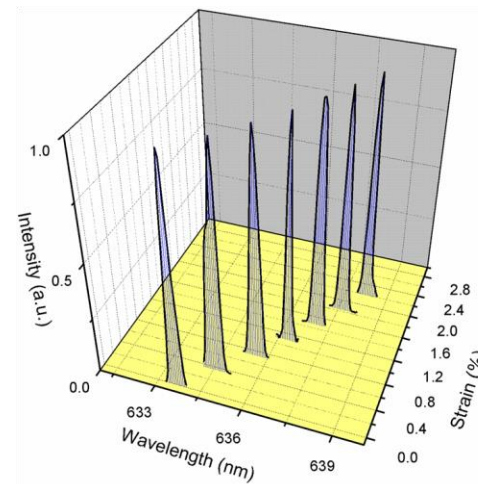
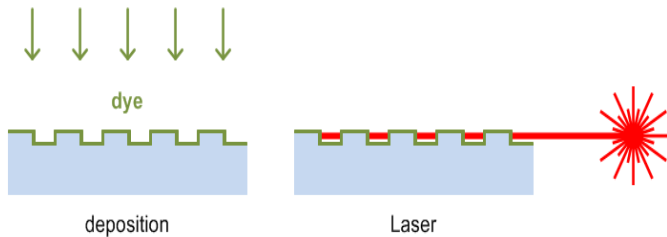
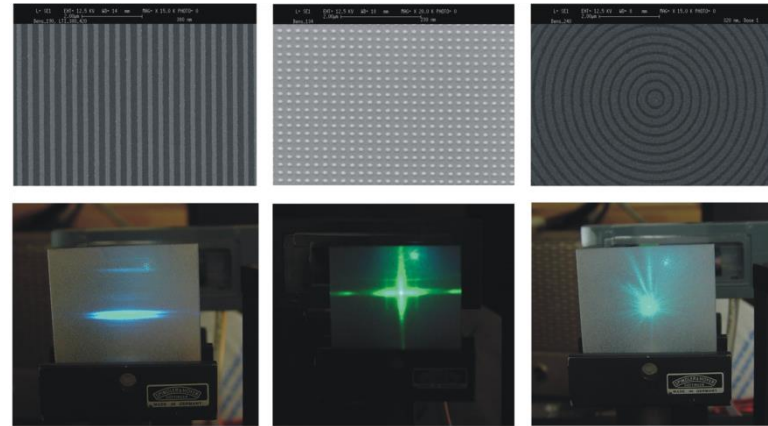
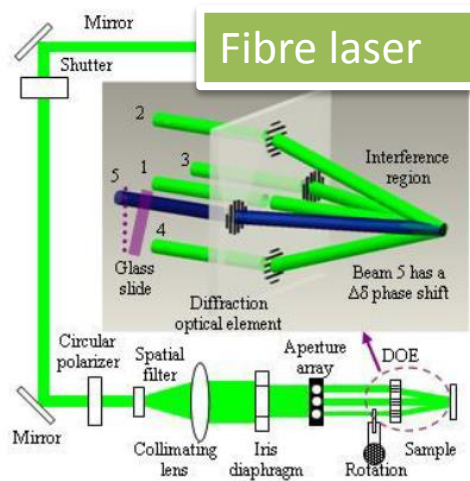


DT-FoF-03-2018: Innovative manufacturing of opto-electrical parts (RIA)

Dr. Jean-Bernard Lecourt



THE CONCEPT



Our project objective:

- Develop an interferometric direct patterning method for the fabrication of compact and low cost planar visible laser sources and bio-sensors on dielectric substrates.



CORE PARTNERS: **Multitel**

Mons, Belgium

Fibre laser source design and process

PARTNER 1:

Fabrication of planar dye lasers

PARTNER 2:

Materials processing, in particular Glass hot embossing

ALREADY CONTACTED:

- RTO for the interferometry system (they were leader of a previous EU project where they developed this type of system).
- RTO (University) for bio-functionalization
- SME for diffractive optics design and fabrication
- _SME (company selling micromachining systems) for machine design and laser integration.

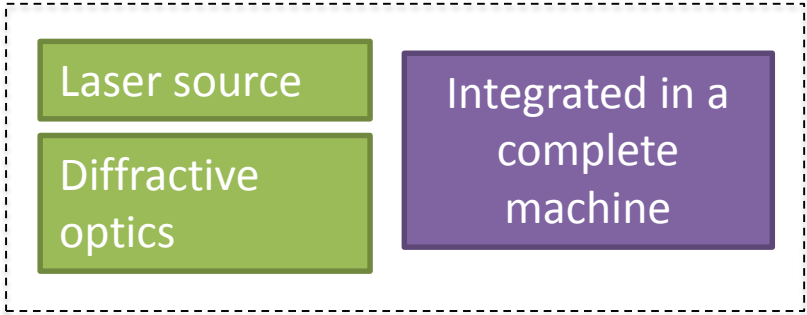
MISSING:

- Partner(s) (At least one company) for the exploitation of the final devices, **with convincing business case. Example: company producing lab-on-chip biosensors**
- RTO or company active on planar devices fabrication, on dielectric substrates.

POSSIBLE PROFILES FOR THE MISSING PARTERS



Process development



FOR

1- Fabrication of planar visible laser sources

2- Fabrication of planar visible laser sources integrated with a sensor

POSSIBLE PROFILES:

- Company producing DFB laser sources
- Company(ies) producing sensors like lab-on-chips and interested by the development of a new product integrating the laser source with the sensor itself. →
No coupling losses on the interrogation phase.

